L Number	Hits		DB	Time stamp
119	110923	(substrate nearl (silicon (lithium near	USPAT;	2003/06/14 15:25
		niobate) (lithium near tantalate) quart))	US-PGPUB;	İ
			EPO; JPO;	
120	12756	((substrate nearl (silicon (lithium near	DERWENT	
120	12/30	niobate) (lithium near tantalate) quart)))	USPAT;	2003/06/14 15:31
		and (transparent window lens) and	US-PGPUB; EPO; JPO;	
	ĺ	(microstructure micromechanical	DERWENT	
		microelectronic optoelectronic optical)	DEKWENT	
121	2	(((substrate near1 (silicon (lithium near	USPAT;	2003/06/14 15:05
		niobate) (lithium near tantalate) quart)))	US-PGPUB;	2003/00/14 13:03
		and (transparent window lens) and	EPO; JPO;	
		(microstructure micromechanical	DERWENT	
	!	microelectronic optoelectronic optical))		
		and crytalline		!
122	3208	(((substrate nearl (silicon (lithium near	USPAT;	2003/06/14 15:12
	1	niobate) (lithium near tantalate) quart)))	US-PGPUB;	
		and (transparent window lens) and	EPO; JPO;	!
		(microstructure micromechanical	DERWENT	
	i i	microelectronic optoelectronic optical))		
123		and crystalline ((((substrate nearl (silicon (lithium near	HCDAM	2002/05/24 45 5
		niobate) (lithium near tantalate) quart)))	USPAT;	2003/06/14 15:24
		and (transparent window lens) and	US-PGPUB; EPO; JPO;	
		(microstructure micromechanical	DERWENT	
		microelectronic optoelectronic optical))	DEKARMI	
		and crystalline) and (csp (chip adj (sized		
		scale) adj package))		
124	332	((((substrate nearl (silicon (lithium near	USPAT;	2003/06/14 15:09
		niobate) (lithium near tantalate) quart)))	US-PGPUB;	
		and (transparent window lens) and	EPO; JPO;	
		(microstructure micromechanical	DERWENT	
		microelectronic optoelectronic optical))		
		and crystalline) and (bump ball csp (chip		
125	331	adj (sized scale) adj package))		
12.5	331	<pre>((((substrate near1 (silicon (lithium near niobate) (lithium near tantalate) quart)))</pre>	USPAT;	2003/06/14 15:10
i		and (transparent window lens) and	US-PGPUB;	
		(microstructure micromechanical	EPO; JPO; DERWENT	
		microelectronic optoelectronic optical))	DEKWENT	
		and crystalline) and (bump ball)		
126	165	((((substrate nearl (silicon (lithium	USPAT;	2003/06/14 15:10
		near niobate) (lithium near tantalate)	US-PGPUB;	
		quart))) and (transparent window lens) and	EPO; JPO;	
	i	(microstructure micromechanical	DERWENT	
		microelectronic optoelectronic optical))		
		and crystalline) and (bump ball)) and		
127	201	adhesive		0000 40 5 11
17.1	204	(((((substrate near1 (silicon (lithium	USPAT;	2003/06/14 15:11
		near niobate) (lithium near tantalate) quart))) and (transparent window lens) and	US-PGPUB;	
i		(microstructure micromechanical	EPO; JPO; DERWENT	
		microelectronic optoelectronic optical))	DERWENT	
		and crystalline) and (bump ball)) and	İ	
		(adhesive epoxy)		
128	362	((substrate nearl (silicon (lithium near	USPAT;	2003/06/14 15:25
		<pre>niobate) (lithium near tantalate) quart)))</pre>	US-PGPUB;	2003/00/14 13:23
		and (csp (chip adj (sized scale) adj	EPO; JPO;	
İ		package))	DERWENT	
129	113684	(substrate near1 (crystalline silicon	USPAT;	2003/06/14 15:25
		(lithium near niobate) (lithium near	US-PGPUB;	
ĺ		tantalate) quart))	EPO; JPO;	
1.20	202		DERWENT	!
130	362	((substrate near) (crystalline silicon	USPAT;	2003/06/14 15:26
		(lithium near niobate) (lithium near	US-PGPUB;	
ļ	1	tantalate) quart))) and (csp (chip adj	EPO; JPO;]
		(sized scale) adj package))	DERWENT	I

Γ <u>131</u> -	T145	(((substrate nearl (crystalline silicon	TUSPAT;	12002/06/14 15 22
1 101	1 143	(lithium near niobate) (lithium near		2003/06/14 15:38
		tantalata (mant)) and (mant him hear	US-PGPUB;	
		tantalate) quart))) and (csp (chip adj	EPO; JPO;	
		(sized scale) adj package))) and	DERWENT	
		(transparent light image lens		
132	37	optoelectronic optical)		
	3/	(((substrate near1 (crystalline silicon	USPAT;	2003/06/14 15:38
		(lithium near niobate) (lithium near	US-PGPUB;	
		tantalate) quart))) and (csp (chip adj	EPO; JPO;	
		(sized scale) adj package))) and	DERWENT	
		(microstructure micromechanical		
	000	microelectronic)		
133	282	((substrate nearl (crystalline silicon	USPAT;	2003/06/14 15:38
		(lithium near niobate) (lithium near	US-PGPUB;	
	1	tantalate) quart))) near3 (microstructure	EPO; JPO;	
		micromechanical microelectronic	DERWENT	
1.104		micromachine)		
134	142	(((substrate nearl (crystalline silicon	USPAT;	2003/06/14 15:39
		(lithium near niobate) (lithium near	US-PGPUB;	
		tantalate) quart))) near3 (microstructure	EPO; JPO;	
!		micromechanical microelectronic	DERWENT	
		micromachine)) and (transparent lens		
		optoelectronic optical)		i
135	33	((((substrate nearl (crystalline silicon	USPAT;	2003/06/14 15:39
		(lithium near niobate) (lithium near	US-PGPUB;	}
		tantalate) quart))) near3 (microstructure	EPO; JPO;	
		micromechanical microelectronic	DERWENT	
		micromachine)) and (transparent lens		
	L	optoelectronic optical)) and cavit\$2		